

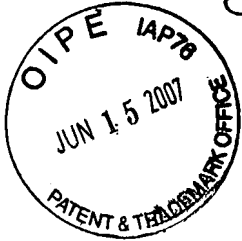
**CERTIFICATE OF MAILING**

I hereby certify that this paper and every paper referred to therein as being enclosed is deposited with the U.S. Postal Service as first class mail, postage prepaid, in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

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PATENT



**Attorney Docket No. 006915 P06**

RW Ref. No.: APM/001-02-CP1-6

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: :  
Kenneth COLLINS, et al. :  
: Group Art Unit: 2812  
Entitled: PLASMA IMMERSION ION :  
IMPLANTATION PROCESS USING AN :  
INDUCTIVELY COUPLED PLASMA SOURCE :  
HAVING LOW DISSOCIATION AND LOW :  
MINIMUM PLASMA VOLTAGE :  
: Examiner: Alexander Ghyka  
Serial No.: 10/646,467 :  
Filing Date: August 22, 2003 :

**AMENDMENT UNDER 37 CFR 1.111**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated February 26, 2007, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 18 of this paper.